



Atty. Dkt. No. 064951-0204

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Robert BELLMAN et al.

Title: USING DEUTERATED SOURCE GASSES TO FABRICATE LOW LOSS GeSiON SiON WAVEGUIDES

Appl. No.: 10/608,432

Filing Date: 6/30/2003

Examiner: Hae M. Hyeon

Art Unit: 2839

**AMENDMENT UNDER 37 CFR 1.312**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants acknowledge receipt of a Notice of Allowance in the above-captioned application. Prior to payment of the issue fee, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this document.

**Remarks** begin on page 3 of this document.

Please amend the application as follows: